



Docket No.: SON-2612/DIV
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shigeru Fujita

Application No.: 10/785,005

Confirmation No.: 9742

Filed: February 25, 2004

Art Unit: 2814

For: SEMICONDUCTOR DEVICE AND ITS
MANUFACTURING METHOD

Examiner: LE, Thao X

AMENDMENT AFTER FINAL OFFICE ACTION UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated May 23, 2006, Applicant respectfully requests reconsideration of the claims in the above-referenced patent application.

A complete listing of the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

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